


## POWER OF ATTORNEY OR AUTHORIZATION OF AGENT

Electronic Version v05

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<b>Title of Invention</b>	Method of Forming Thin Silicon Oxide Films on Silicon Carbide Substrates
First Named Applicant :	Andrew M. Hoff
Attorney Docket Number :	1372.80.PRC
I hereby appoint the registered practitioner(s) at Customer Number:	
21901	
as attorney(s) or agent(s) to prosecute the application identified above, and to transact all business in the United States Patent and Trademark Office connected therewith.	
I am the Applicant/Inventor.	
Full Name of Applicant of Record:	
Andrew M. Hoff	
Signature: /andrew m hoff/	Date: 2003-10-13